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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/796,146	03/10/2004	Mizuhisa Nihei	040102	2043	
23850 7590 06/18/2007 ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP			EXAMINER		
1725 K STREE	1725 K STREET, NW			PHAM, THANHHA S	
SUITE 1000 WASHINGTON, DC 20006			ART UNIT	PAPER NUMBER	
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			MAIL DATE	DELIVERY MODE	
-			06/18/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)				
	10/796,146	NIHEI ET AL.				
Office Action Summary	Examiner	Art Unit				
	Thanhha Pham	2813				
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the	correspondence address				
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING D/ Extensions of time may be available under the provisions of 37 CFR 1.1: after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period v Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be to the second will expire SIX (6) MONTHS from the cause the application to become ABANDON	N). imely filed m the mailing date of this communication. ED (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on 12 M	larch 2007.					
2a)⊠ This action is FINAL . 2b)☐ This	This action is FINAL . 2b) This action is non-final.					
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 4	153 O.G. 213.				
Disposition of Claims						
 4) Claim(s) 1-29 is/are pending in the application. 4a) Of the above claim(s) 11-29 is/are withdraw 5) Claim(s) is/are allowed. 6) Claim(s) 1-8 and 10 is/are rejected. 7) Claim(s) 9 is/are objected to. 8) Claim(s) are subject to restriction and/o 	vn from consideration.					
Application Papers						
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomplicated any not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Examine	epted or b) objected to by the drawing(s) be held in abeyance. So ition is required if the drawing(s) is o	ee 37 CFR 1.85(a). bjected to. See 37 CFR 1.121(d).				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority documents 2. Certified copies of the priority documents 3. Copies of the certified copies of the priority application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applica rity documents have been receiv u (PCT Rule 17.2(a)).	tion No ved in this National Stage				
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summar Paper No(s)/Mail I 5) Notice of Informal 6) Other:	Date				

DETAILED ACTION

This Office Action is in response to Applicant Amendment dated 3/12/2007.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

- 1. Claims 2-6 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- With respect to claim 2,

line 4, "the film on the heat conductor" lacks antecedent basis. Moreover, scope of claim is not clear. It is not clear that which element on the heat conductor – a second hole on the heat conductor or just the film being on the heat conductor.

Applicant is respectfully to clarify and use appropriate consisting claimed language to clarify scope of claim.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

⁽b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

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1. Claims 1, 7, 8 and 10 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Chen [US 6,191,478].

► With respect to claim 1, Chen (fig 5 & 8, cols 1-8) discloses the claimed semiconductor device comprising:

a SiC substrate (25, silicon carbide, col 5 lines 15-21); and

a heat conductor (33, col 5 lines 4-38) formed in a first hole (27) in the SiC substrate and made of linear structure of carbon elements (carbon fiber),

wherein a diameter of the heat conductor is the same as a diameter of the first hole.

▶ With respect to claim 7, Chen (fig 5, 7 & 8, cols 1-8) discloses the claimed semiconductor device comprising:

a SiC substrate (25, silicon carbide, col 5 lines 15-21)having a first surface and a second surface;

a first heat conductor (33a, col 5 lines 4-38) formed in a first hole (27a, col 8 lines 38-55) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber);

a second heat conductor (33b, col 5 lines 4-38) formed in a second hole (27b) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber); and

an element (61, fig 7) formed on the second surface of the SiC substrate,

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wherein a diameter of the first heat conductor is the same as a diameter of the first hole and a diameter of the second heat conductor is the same as a diameter of the second hole.

- With respect to claim 8, the claimed distance from the second surface of the SiC substrate to an upper surface of the second heat conductor relative (longer) to a distance from the second surface of the SiC substrate to an upper surface of the first heat conductor would have been obvious to an ordinary artisan practicing the invention because, absent evidence of disclosure of criticality for the range giving unexpected results, it is not inventive to discover optimal or workable ranges by routine experimentation. In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955). Furthermore, it appears that these changes produce no functional differences and therefore would have been obvious. See In re Woodruff, 919 F.2d 1575, 1578, 16 USPQ2d 1934, 1936 (Fed. Cir. 1990).
- ▶ With respect to claim 10, Chen (fig 5, 7 & 8, cols 1-8) discloses the claimed semiconductor device comprising:

a SiC substrate (25, silicon carbide, col 5 lines 15-21) having a first surface (the surface of the substrate 25 that defines hole 27b -- wall and bottom of hole 27b) and a second surface:

a first heat conductor (33a, col 5 lines 4-38) formed in a hole (27a, col 8 lines 38-55) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber);

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a second heat conductor (33b, col 5 lines 4-38) formed to cover the first surface of the SiC substrate entirely (second heat conductor 33b filling hole 27b would inherently entirely cover the first surface since the first surface of the substrate 25 is the surface that define the hole 27b) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber); and

an element (61, fig 7) formed on the second surface of the SiC substrate, wherein a diameter of the first heat conductor is the same as a diameter of the hole.

Allowable Subject Matter

- 2. Claim 9 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 3. The following are statements of reasons for the indication of allowable subject matter:
- ▶ Recorded Prior Art fails to disclose or suggest the combination structure of the semiconductor as recited in the base claim 7 wherein the element is an HEMT and at least a part of the second heat conductor located between a gate electrode and a drain electrode of the HEMT when viewed from above the SiC substrate as characteristics in claim 9.

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Response to Arguments

4. Applicant's arguments with respect to claims 1-8 and 10 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

5. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanhha Pham whose telephone number is (571) 272-1696. The examiner can normally be reached on Monday and Thursday 9:00AM - 9:30PM.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

TSP

THANHHA S. PHAM PRIMARY EXAMINER